

12/27/01
1131 U.S. PTO

JC927 U.S. PTO
10/026551
12/27/01

Docket No.: 50006-135

UTILITY PATENT APPLICATION
UNDER 37 CFR 1.53(b)

Box PATENT APPLICATION
Commissioner for Patents
Washington, DC 20231
Sir:

Transmitted herewith for filing is the patent application of:

INVENTOR: Tomohiro HOSOKAWA, Satoshi SHIMIZU
FOR: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND
SYSTEM FOR MANUFACTURING THE SAME

Enclosed are:

- ☒ 25 pages of specification, claims, abstract.
☒ Declaration and Power of Attorney.
☒ Priority Claimed.
☒ Certified copy of Japanese Patent Application No. 2000-397501
☒ 10 sheets of formal drawing.
☒ An assignment of the invention to Mitsubishi Denki Kabushiki Kaisha
and the assignment recordation fee.
☐ An associate power of attorney.
☐ A verified statement to establish small entity status under 37 CFR 1.9 and 37 CFR 1.27.
☒ Information Disclosure Statement, Form PTO-1449 and references.
☒ Return Receipt Postcard
☐

The filing fee has been calculated as shown below:

	NO. OF CLAIMS		EXTRA CLAIMS	RATE	AMOUNT
Total Claims	14	-20	0	\$18.00	\$0.00
Independent Claims	2	-3	0	\$84.00	\$0.00
Multiple Dependent Claim(s)					\$0.00
Basic Fee					\$740.00
Total of Above Calculations					\$740.00
Less ½ for Small Entity					\$0.00
Assignment & Recording Fee					\$40.00
Total Fee					\$780.00



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PATENT TRADEMARK OFFICE

